



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 19, 2026	
IGI Report Number	LG775626067
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MARQUISE BRILLIANT
Measurements	12.33 X 5.95 X 3.62 MM

GRADING RESULTS

Carat Weight	1.51 CARAT
Color Grade	E
Clarity Grade	VS2

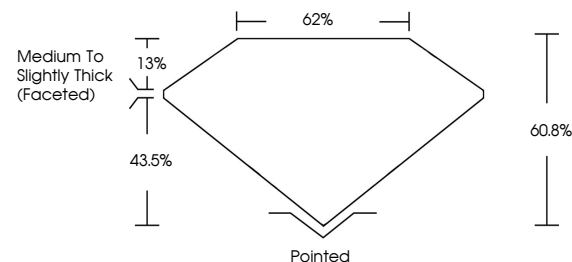
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG775626067

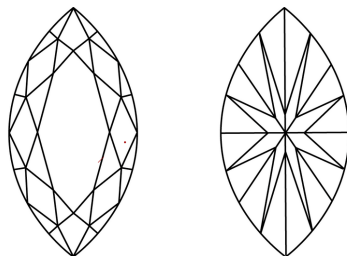
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG775626067
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

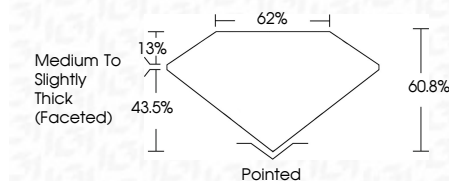
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www.igi.org

February 19, 2025	1.51 CARAT
GI Report No. LG775626057	VVS 2
MANQUE BRILLANT	60.9%
	62%
	Medium to Slightly Thick (Faceted)
	Pointed
	EXCELLENT
	EXCELLENT
	NONE
	1691 LG775626057

Comments: The laboratory grown diamond was produced by the Chemical Vapor Deposition (CVD) growth process.

Type IIG